

**INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION**

(Use several sheets if necessary)

Attorney Docket No.:  
**03P19405**Application No.:  
**NEW NATIONAL PHASE**Applicant:  
**Tim FIEDLER et al.**

DT05 Rec'd PCT/PTO 03 FEB 2005

Filing Date:  
**February 3, 2005**

Group Art Unit:

**U.S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)
CMK	4,716,335	12/29/1987	SCHUTTEN et al.			
	4,783,596	11/8/1988	RIEDNER et al.			
	4,810,938	3/7/1989	JOHNSON et al.			
	5,196,763	3/23/1993	YANG et al.			
	5,376,303	12/27/1994	ROYCE et al.			
	5,424,006	6/13/1995	MURAYAMA et al.			
	5,998,925	12/7/1999	SHIMIZU et al.			
	6,632,379	10/14/2003	MITOMO et al.			
	6,700,322	3/2/2004	DUGGAL et al.			
	2002/0137709	9/26/2002	LIN et al.			
CMK	2004/0062699	4/1/2004	OSHIO			

**FOREIGN PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
CMK	2004067837	3/4/2004	JAPAN (ABSTRACT)			X	

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

CMK	By J.W.H. van Krevel, "On new rare-earth doped M-Si-Al-O-N materials, Luminescence properties and oxidation resistance", Technische Universiteit Eindhoven, 2000, ISBN 90-386-2711-4, pages 1-5, 18-27.

EXAMINER:

/C. Melissa Koslow/

DATE CONSIDERED

01/22/2007

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

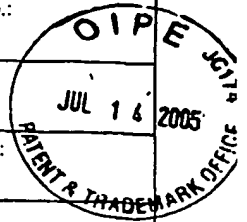
\* English language abstract provided for the Examiner's convenience

(Use several sheets if necessary)

Application No.:  
**10/523,701**

Filing Date:  
**February 3, 2005**

**Group Art Unit:**

[illegible][illegible]

CMK		J. Shmulovich et al., "Single-Crystal Rare-Earth-Doped Yttrium Orthosilicate Phosphors", Journal of the Electrochemical Society, December 1988, No. 12, pages 3141-3151.

/C. Melissa Koslow/

01/22/2007

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* Abstract provided for the Examiner's convenience